

## Affiliate Pricing - Equipment Included in General Rate

Name	Description	Price	Unit
4ptprb	Four Point Probe - Miller Design/Automat	\$0.00	minute
4ptprb2	Four Point Probe - Manual	\$0.00	minute
afm2	Digital Instruments AFM	\$0.00	minute
ahu1a	NanoLab Air Handler Unit 1A	\$0.00	minute
ahu1b	NanoLab Air Handler Unit 1b	\$0.00	minute
aircart	Bullard breathing air protection system	\$0.00	minute
aml-bonder	AML AWB-08 Aligner Wafer Bonder	\$0.00	minute
aptchrome	APT chrome mask developer	\$0.00	minute
aptemul	APT emulsion mask developer	\$0.00	minute
autoprobe	Electroglass Autoprobe in DCL	\$0.00	minute
axcelis	Axcelis photoresist UV bake system	\$0.00	minute
bagsealer	Plastic Bag Thermal Sealer	\$0.00	minute
beadblaster	Bead Blasting Cabinet - 280 SDH	\$0.00	minute
beamer	GenISYS conversion software GDS to CON	\$0.00	minute
bottlewash	For Problem Reports - No Enable Required	\$0.00	minute
bottlewash2	For Problem Reports - No Enable Require	\$0.00	minute
cascade1	Cascade Probe Station - 1	\$0.00	minute
cascade2	Cascade Probe Station - 2	\$0.00	minute
cde-resmap	CDE 4-ptprb Automated Mapper, 2" -12"	\$0.00	minute
cdu	Delatech 859 Thermal Decomposition & Oxi	\$0.00	minute
cpdsink	CPD Sink - Bay 382	\$0.00	minute
dcl	For Problem Reports - No Enable Require	\$0.00	minute
drystation1	Drying Station - Bay 382	\$0.00	minute
edx	Energy-dispersive X-ray Spectroscopy	\$0.00	minute
ellips	Ellipsometer - Gaertner Stokes	\$0.00	minute
etchclass	To track completion of etch class	\$0.00	minute
evapclass	To track completion of evap class	\$0.00	minute
facility	To Report NanoLab Building Problems	\$0.00	minute
finetech	Finetech Die Attachment Bonder	\$0.00	minute
ftir	General use FFT Infrared Spectrometer	\$0.00	minute
glasswafer-class	Borofloat wafer use qualifications	\$0.00	minute
glovebox	Glovebox for Pyrophoric Materiel Handlin	\$0.00	minute
glovebox2	Glovebox for Inert Atmosphere	\$0.00	minute
grinder	Techdian substrate grinder	\$0.00	minute
headway1	Headway Spinner In msink3	\$0.00	minute
headway2	Headway Spinner - Standalone	\$0.00	minute
hld	Alcatel Model 180 T Helium Leak Detector	\$0.00	minute
hld2	Alcatel Model 180 TD Helium Leak Detecto	\$0.00	minute
hotplates	Hotplates	\$0.00	minute
ircam	Infrared Source & Video Camera	\$0.00	minute

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irscope	Infrared Microscope	\$0.00	minute
kruss	Kruss Contact Angle Analyzer	\$0.00	minute
lapper	Techdia substrate lapper	\$0.00	minute
linewidth	Linewidth & Feature Measuring System	\$0.00	minute
linewidth2	Zeiss Feature Measuring Microscope	\$0.00	minute
maskcopy	Ultratech mask copier	\$0.00	minute
matrix	Matrix 106 Resist Remover	\$0.00	minute
mesc	Mobile electrostatic chuck	\$0.00	minute
metricon	Prism-coupled refractive index analyzer	\$0.00	minute
microscope1	Nikon Optiphot 200 located in Bay 384	\$0.00	minute
microscope2	Nikon Optiphot 150 in bay 384	\$0.00	minute
microscope3	Leitz Ergolux in bay 382	\$0.00	minute
microscope4	Leitz Metalloplan in PG area, bay 382A	\$0.00	minute
microscope5	MM Stereo-scope in Bay 380	\$0.00	minute
microscope6	Leitz Secolux in FEI room 131	\$0.00	minute
microscope7	WILD M450 Stereo-scope	\$0.00	minute
msink1	Tank Photoresist Strip and Develop	\$0.00	minute
msink10	Red-room msink	\$0.00	minute
msink12	Compound semiconductor processin	\$0.00	minute
msink14	Epi Si/Ge deposition pre-clean	\$0.00	minute
msink16	General purpose fume hood/wet process	\$0.00	minute
msink18	General purpose fume hood/wet process	\$0.00	minute
msink2	Heated Strip and Manual Develop Station	\$0.00	minute
msink20	General purpose fume hood/wet process st	\$0.00	minute
msink3	SS, manual lithography, headway spinner	\$0.00	minute
msink4-koh	KOH Etching Bath of msink4	\$0.00	minute
msink4-tmah	TMAH Etch Bath - msink4	\$0.00	minute
msink5	HF release etch wet process station	\$0.00	minute
msink6	furnace pre-clean	\$0.00	minute
msink7	Hot Phosphoric, HF, Silicon Etch (Bay 38	\$0.00	minute
msink8	post PR cleaning	\$0.00	minute
nanoduv	Nanospec/DUV Microspectrophotometer	\$0.00	minute
nanospec	Nanospec AFT film thickness measuring sy	\$0.00	minute
nanospec-cmp	NanoSpec AFT film thickness monitor	\$0.00	minute
netscope	Leica IMN200 Microscope	\$0.00	minute
nrc	NRC evaporator	\$0.00	minute
orbital-welder1	ARC Model 207 Welder	\$0.00	minute
orbital-welder2	ARC Model 217 Welder	\$0.00	minute
oven	NanoLab Ovens	\$0.00	minute
primeoven	Yield Engineering Systems YES - 5	\$0.00	minute

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probe-eb8	Everbeing Probe Station with Hot Chuck	\$0.00	minute
quintel	Quintel Q4000-6IR Contact Printer	\$0.00	minute
raman-scope	Laser-based Raman Spectroscopic Microsco	\$0.00	minute
reichert	Reichert Polylite inspection microscope	\$0.00	minute
sem-coater	Denton II Desktop SEM AU/Pd Coater	\$0.00	minute
sinkcmp	CMP Wet-sink	\$0.00	minute
sinkcmp2	Sink in 582A for dicso and gnpcomp	\$0.00	minute
sp3seeding	sp3 Diamond Wafer Seeding	\$0.00	minute
srdmsink1	Spin Rinser Dryer at mskin1 - Verteq	\$0.00	minute
srdmsink14	Semitoool Spin Rinse Dryer at msink14	\$0.00	minute
srdmsink2	Spin Rinse Dryer at msink2	\$0.00	minute
srdmsink6	Semitoool Spin Rinse Dryer 880-S	\$0.00	minute
srdmsink8	Verteq Spin Rinser Dryer	\$0.00	minute
technics-c	Technics VLSI plasma etch	\$0.00	minute
tensiometer	Sigma 701 Tensionmeter	\$0.00	minute
utilitysink397	Utility sink - Chase 397	\$0.00	minute
utilitysink595	Utility sink - Chase 595	\$0.00	minute
uvflood	Dymax 2000 - Timed UV Flood Exposures	\$0.00	minute
uvscope	Leica I-line Microscope	\$0.00	minute
vacoven	YES (Yield Eng. Systems) 450PBS-29	\$0.00	minute
vacoven2	Vacuum Oven adjacent to sem-coater	\$0.00	minute
vcseiox	AET III-V Oxidation Furnace	\$0.00	minute
vwr2	VWR Bake Oven	\$0.00	minute
yes-g500	YES-G500 Plasma Cleaning System	\$0.00	minute